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Artificial Intelligence for Medical Image Analysis

Guest Editor:

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Deadline for manuscript submissions: closed (10 May 2021)

Message from the Guest Editor

Dear Colleagues,

Deep learning approaches have demonstrated exceptional performance in the screening and diagnosis of many diseases. A further challenge of Al-driven solutions is to develop tools for a personalized disease assessment through deep learning models by taking advantage of their ability to learn patterns and relationships in data, utilizing massive volumes of medical images, and combining radiomics extracted from them with other forms of medical data.

With the above mentioned in mind, this Special Issue aims to promote the latest cutting edge Al-driven research in medical image processing and analysis. Of particular interest are submissions regarding computer-aided diagnosis and improvement of automated image interpretation. However, contributions concerning other aspects of medical image processing (including, but not limited to image quality improvement, image restoration, image segmentation, image registration, radiomics analysis) are also welcomed.

Dr. Hab. Anna Fabijańska *Guest Editor*









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Editor-in-Chief

Message from the Editor-in-Chief

Prof. Dr. Giulio Nicola Cerullo Dipartimento di Fisica, Politecnico di Milano, Piazza L. da Vinci 32, 20133 Milano, Italy As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal Applied Sciences has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multi-dimensional network.

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